

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : ESASHI Masayoshi, et al
Int'l Appln. No. : PCT/JP00/02739
Int'l Filing Date : April 27, 2000
Title of Invention : METHOD OF MANUFACTURING A
MICROMACHINE

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Date of Deposit: October 25, 2001

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Enclosed are copies of the publications, which were cited in the International Search Report of International Application No. PCT/JP00/02739. Also enclosed is a copy of Form PTO-1449 and the International Search Report.

PATENT

450104-03688

30 9 1997 25 OCT 1997

REMARKS

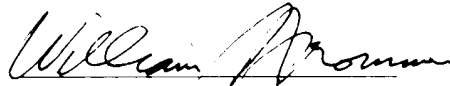
Entry of this Information Disclosure Statement and an early examination on the merits are respectfully solicited.

Please charge any additional fees to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP

By:



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WSF/ yrp
Enclosures

10/019809

3 Rev 6 PTO/F 25 OCT 2001
Sheet 1 of 1

Based on Form PTO-1449 (3-99) LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)	ATTORNEY DOCKET NO. 450104-03688	SERIAL NO.
	APPLICANT ESASHI Masayoshi, et al	
	FILING DATE Filed Concurrently	GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	5,955,776	09 21 99	Ishikaa			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AK	9-288124	11 04 97	Japan				
	AL	10-96741	04 14 98	Japan				
	AM	10-154820	06 09 98	Japan				
	AN	10-313139	11 24 98	Japan				
	AO	6-335265	12 02 94	Japan				
	AP	98 25090	06 11 98	WIPO				
	AQ	1239543	12 22 99	China				
	AR	360909	06 11 99	Taiwan				
	AS							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AI	Norio Takeda et. al., "Ball Semiconductor Gijutsu to MEMS sensor e no Oyo", IEEEJ Kenkyukai Shiryou, SMP 99-5-9, 23 July 1999, pp. 1-6
AU	Masaki Yamashita et. al., "Kyumen Handoutai no Kangae Kata to Sono Kaihatsu Jokyo", Denshi Zairyo, vol. 37, no. 11, 1998, pp. 21-26

EXAMINER	DATE CONSIDERED
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 6-09. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.